IN THE CLAIMS:

Please amend the claims as follows:

1. (Original) A thin-film magnetic head having an MR head portion containing magnetoresistive elements, wherein a protective film having the composition represented by the following formula:

(where a = 0 - 0.7, b = 0 - 1, c = 0 - 1, d = 0 - 1, e = 0 - 1, and f = 0 - 1, in terms of atomic ratio), and having a thickness of 40 Å or less, is formed on at least the surface of said MR head portion facing a recording medium.

- 2. (Original) The magnetic head according to Claim 1, wherein the thickness of said protective film is 10 30 Å.
- 3. (Currently Amended) The magnetic head according to Claim 1 or 2, wherein a = 0.05 0.7.
- 4. (Currently Amended) A method for producing a thin-film magnetic head, wherein comprising conducting vapor deposition is conducted on at least the <u>a</u> surface of said thin-film magnetic head facing a recording medium until a film having a thickness of 40 Å or less is formed, by using material gas that is adjusted so as to form a diamond-like protective film having the composition represented by the following formula:

$$CH_a O_b N_c F_d B_e P_f$$

(where
$$a = 0 - 0.7$$
, $b = 0 - 1$, $c = 0 - 1$, $d = 0 - 1$, $e = 0 - 1$ and $f = 0 - 1$).

- 5. (Original) The method according to Claim 4, wherein vapor-phase etching is conducted prior to the formation of the diamond-like protective film on the surface of the thin-film magnetic head.
- 6. The method according to Claim 4 or 5, wherein vapor deposition is conducted by applyin a negative bias voltage to the thin-film magnetic head.
- 7. (Currently Amended) The method according to any one of Claims Claim 4 to 6, wherein the thickness of said protective film is 10 30 Å.
- 8. (Currently Amended) The method according to any one of Claims Claim 4 to 7, wherein a = 0.05 0.7.
- 9. (Original) A magnetic disk device having at least one slider equipped with the thin-film magnetic head according to Claim 1.
 - 10. (New) The magnetic head according to Claim 2, wherein a = 0.05 0.7.